
Coordinating Panel for Advanced Detectors of the Division of Particles and Fields of the American Physical Society

CPAD Instrumentation Frontier Workshop 2021

18 - 22 March 2021, Stony Brook, NY, USA

Blue Sky Session

Silicon Carbide: a new frontier for radiation detectors?

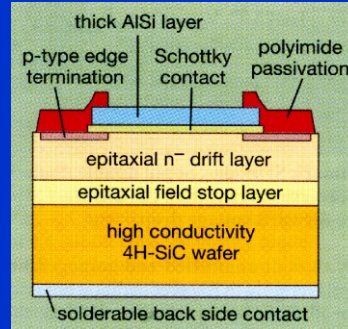
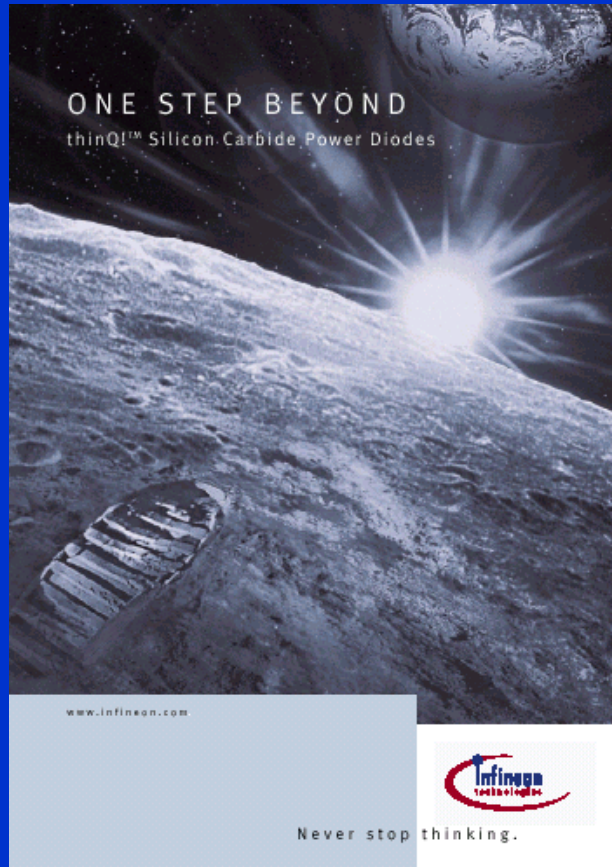
Giuseppe Bertuccio

Politecnico di Milano

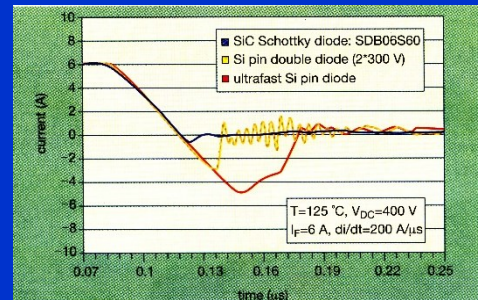
Department of Electronics, Information and Bioengineering
and

National Institute of Nuclear Physics (INFN)
Milan, Italy

April 2001: first commercial SiC Diode



600 V - 4 A
300 V - 10 A



Applications
Compact Switched Mode
Power Supplies

Today industrial SiC devices

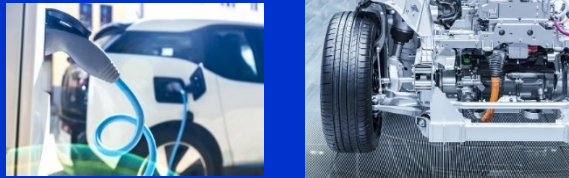
Industrial World is already producing and using SiC devices



MOSFETs and Diodes
600 V – 1.2 kV, up to 150 A



Automotive



High efficiency
AC/DC Converters, Inverters



Renewable energy



USA R&D for SiC & GaN industrial applications



Advancing Silicon Carbide and Gallium Nitride technologies.

PowerAmerica by the numbers

37

INDUSTRY MEMBERS

18

UNIVERSITY PARTNERS

5

NATIONAL
LABS

33

INVENTION
DISCLOSURES FILED

\$140

MILLION IN PROJECT
FUNDING



Advancing Silicon Carbide and Gallium Nitride technologies.

<https://poweramericainstitute.org>



Resources Membership Education and Workforce Development Funding Opportunities Events Latest News



Accelerating the next
generation of power
electronics.



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G. Bertuccio, Silicon Carbide Detectors for Ionizing Radiation: history, state of the art and perspectives
CPAD Instrumentation Frontier Workshop 2021, 18 - 22 March 2021, Stony Brook, NY, USA

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SiC Detector R&D in Italy

Reactor
Engineering
epi-SiC growth

Material
Characterization

Detector / FEE
design & fabrication

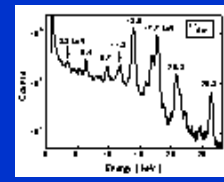
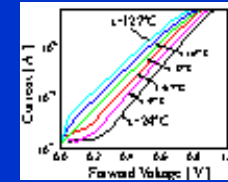
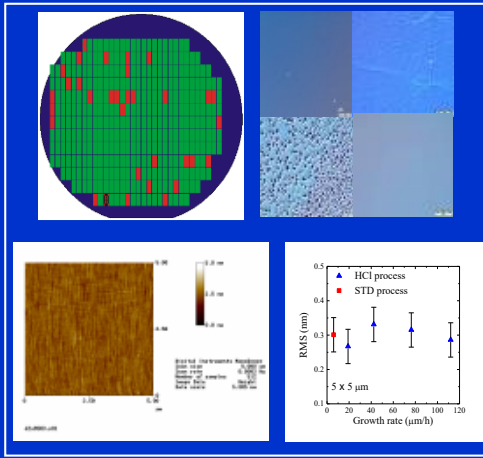
Detector / FEE
characterization



Univ. Bologna, Catania,
Univ. Modena, Torino

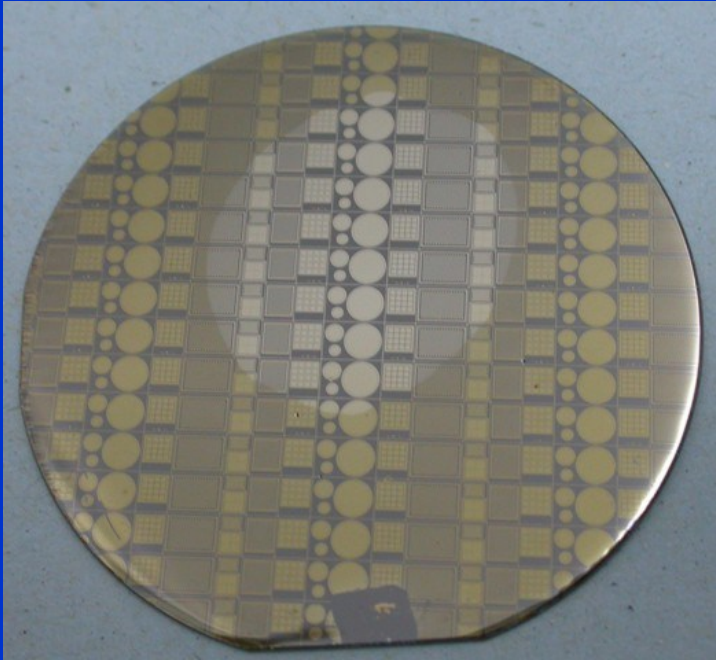
Politecnico di Milano, Univ. Catania

Politecnico di Milano,
Univ. Modena, Catania, Torino

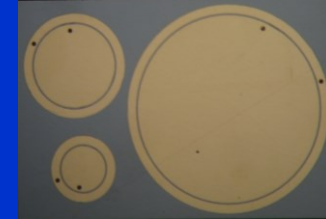
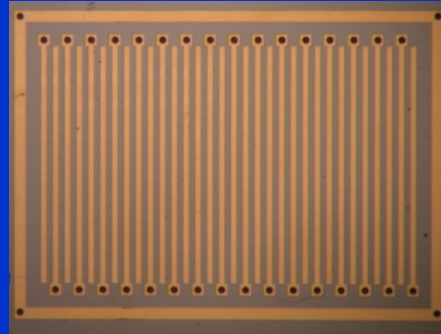


SiC detector prototypes

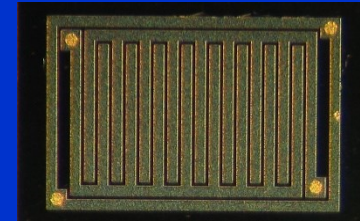
Processed SiC Wafer



Microstrip

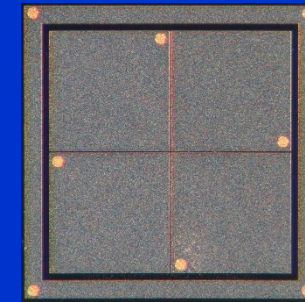
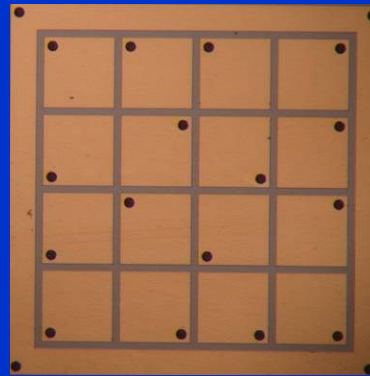


Pad



Interdigitated

Pixel

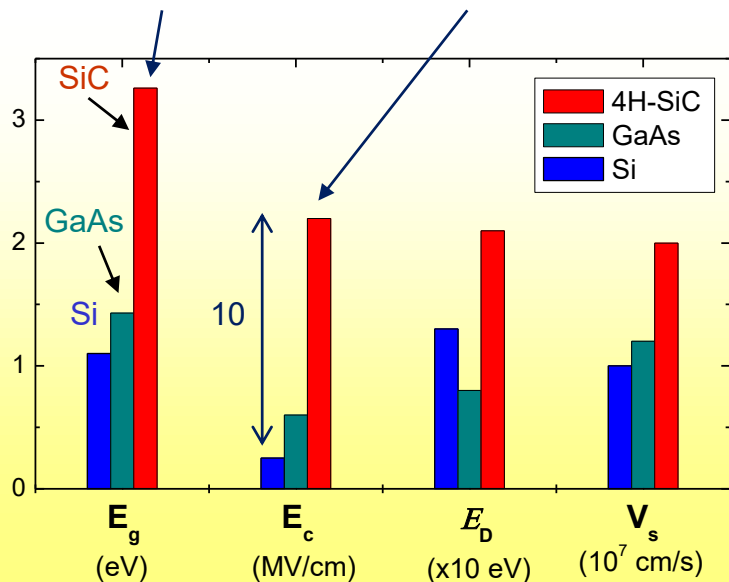


Quad

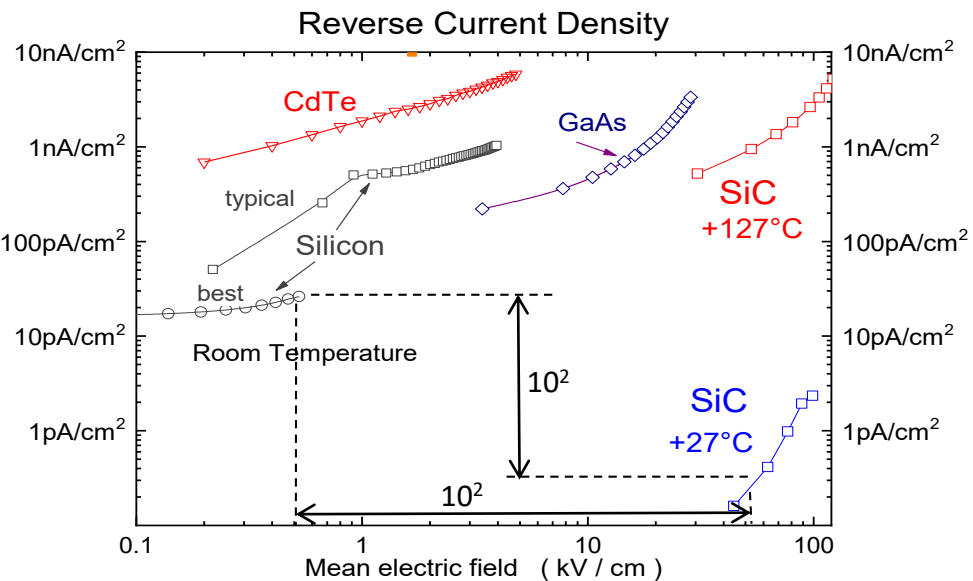
Strength of SiC for Radiation Detection

Wide Bandgap
3.2 eV

High Critical Field
(2 MV/cm)



Experimental Data



$J = 1 \text{ pA/cm}^2$ @ $+27^\circ\text{C}$ → sub-electron ENC
 $J = 1 \text{ nA/cm}^2$ @ $+127^\circ\text{C}$ → High-T operation
 $E = 100 \text{ kV/cm}$ → very fast, no charge trapping

High Resolution X-Ray Spectroscopy with SiC pixel

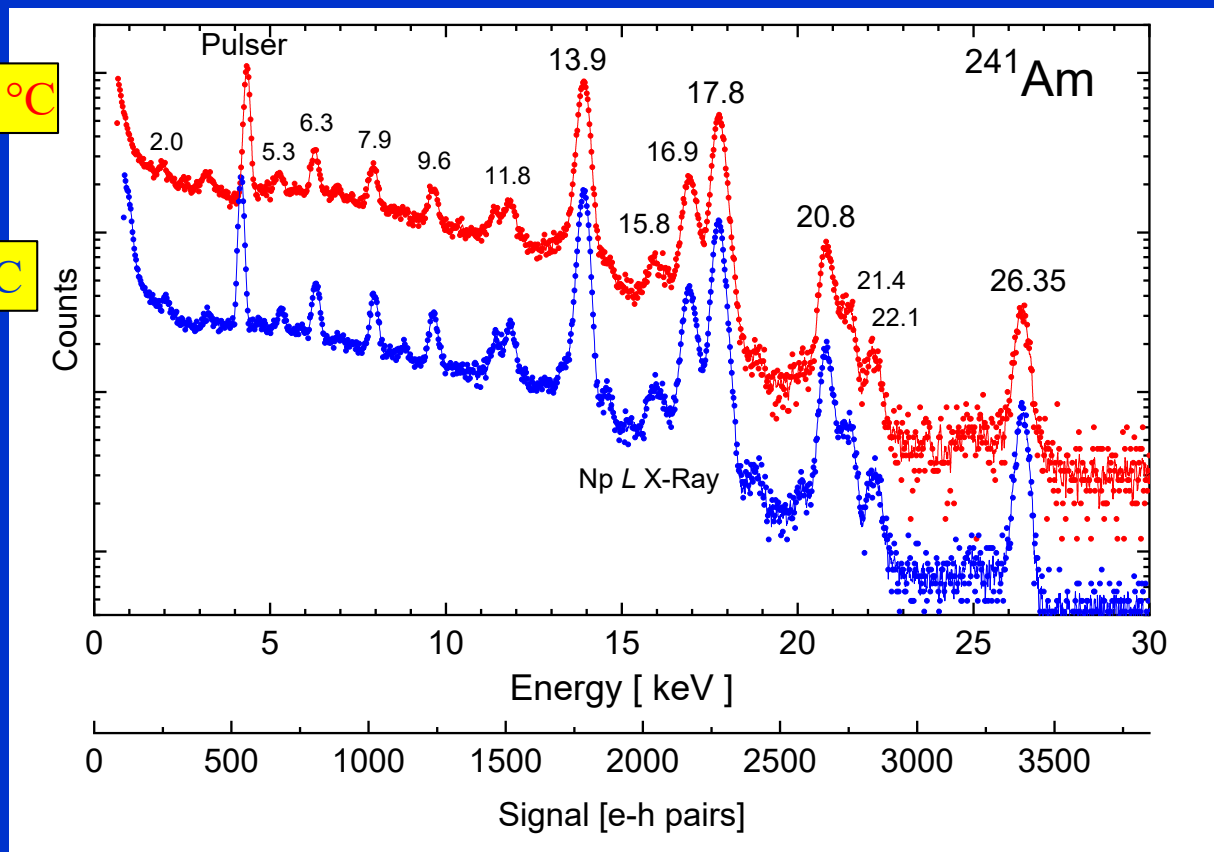
FWHM

177 eV
(9.6 e⁻ rms)

+100 °C

120 eV
(6.5 e⁻ rms)

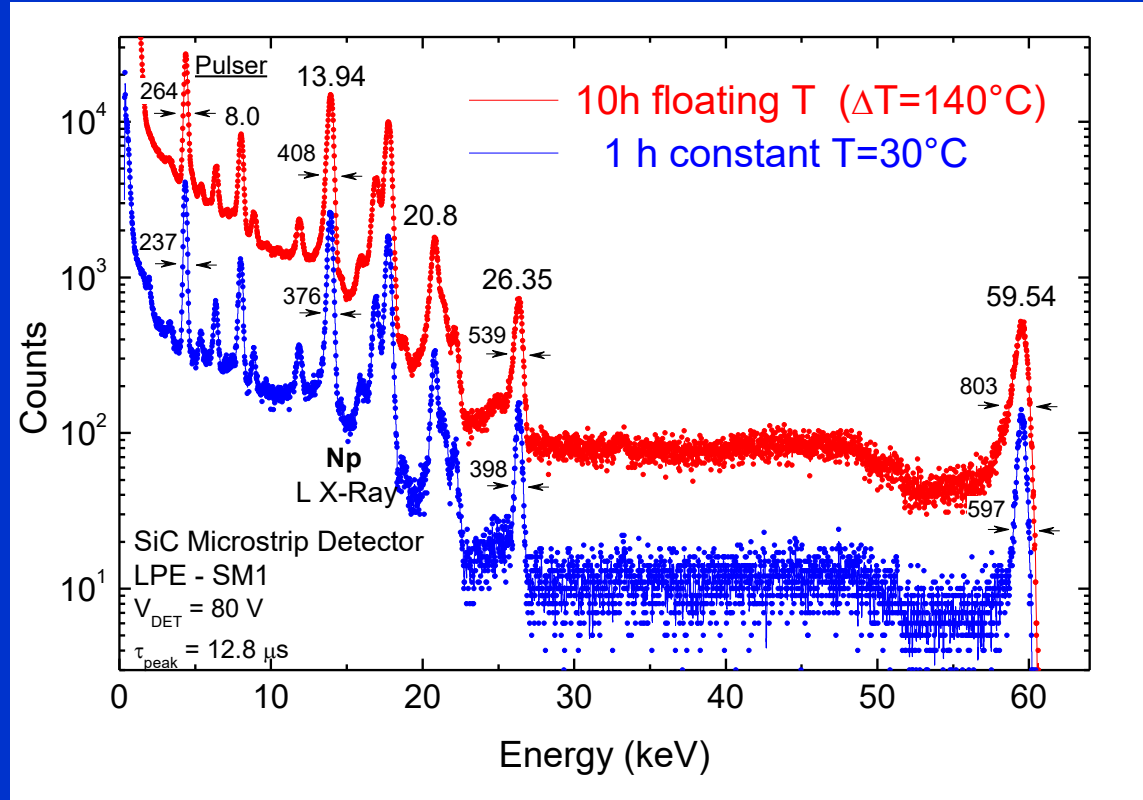
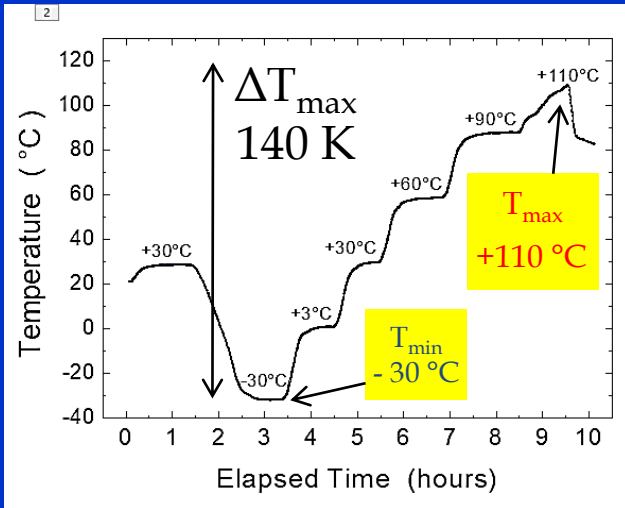
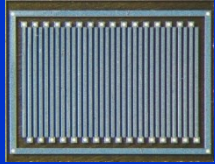
+28 °C



SiC detector under floating temperature

Bandgap energy (e-h pair creation energy) : minimum temperature coefficient

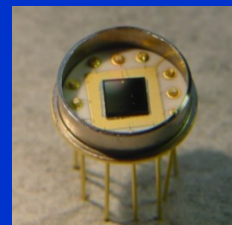
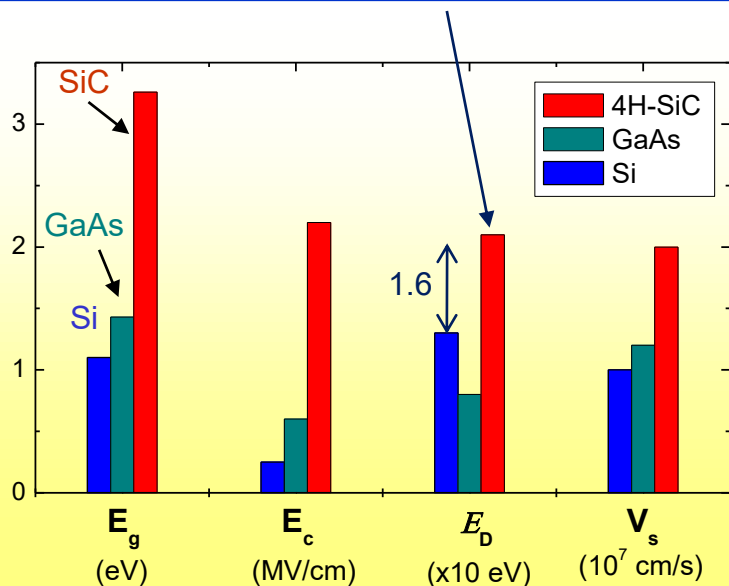
SiC microstrip detector



Strength of SiC for Radiation Detection

High Atom Displacement Energy
(22 / 35 eV)

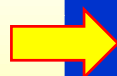
Experimental Data



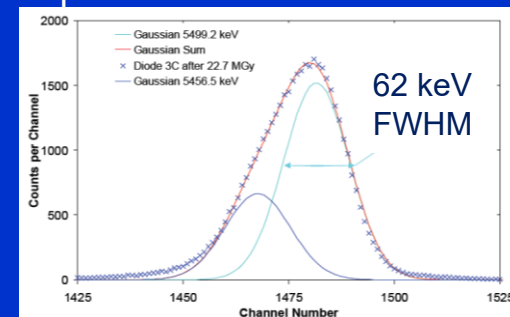
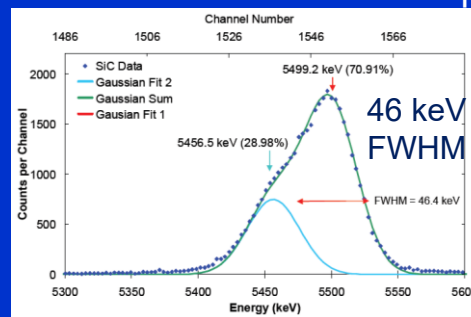
Before irradiation



After 23 MGy of ^{137}Cs



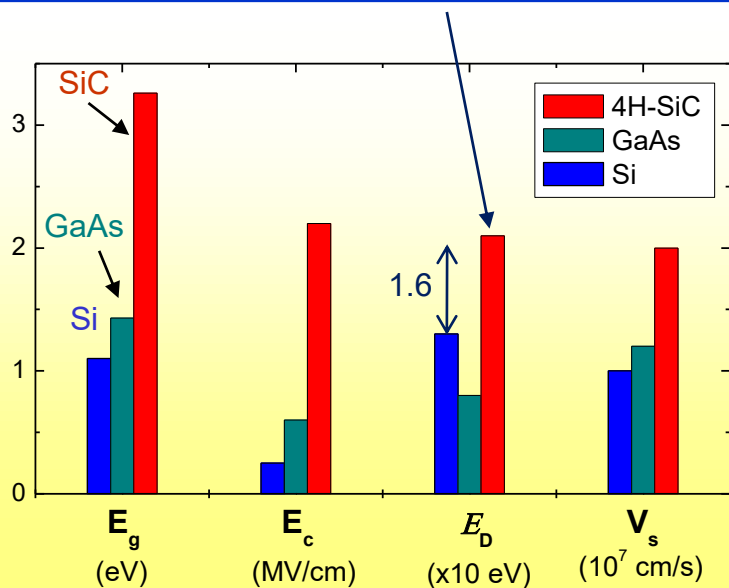
^{238}Pu alpha spectra



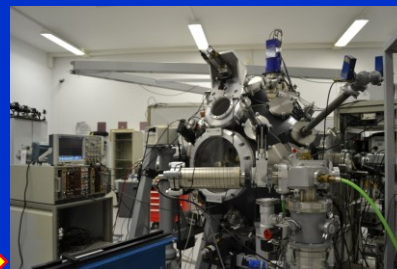
Courtesy of F. H. Ruddy, Westinghouse

Strength of SiC for Radiation Detection

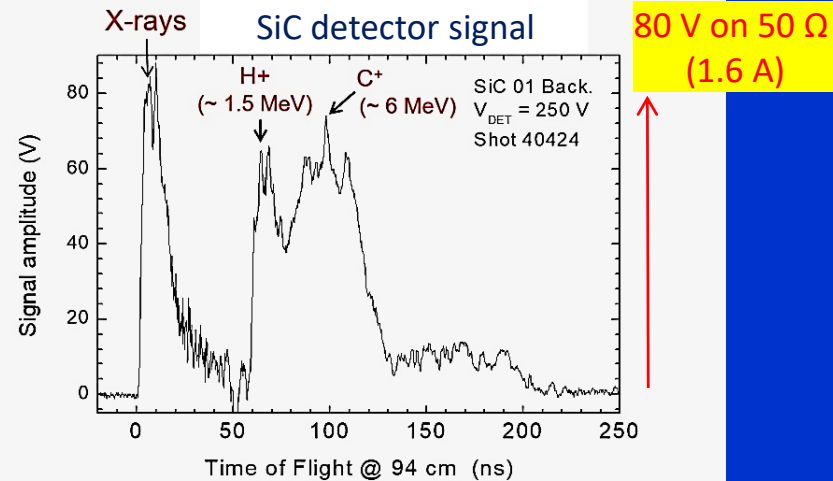
High Atom Displacement Energy
(22 / 35 eV)



Experimental Data
Plasma radiation



Asterix – PALS (Prague)
High Power Laser
3 TW / 1 J / 350 ps Laser

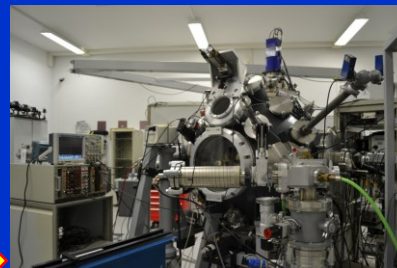
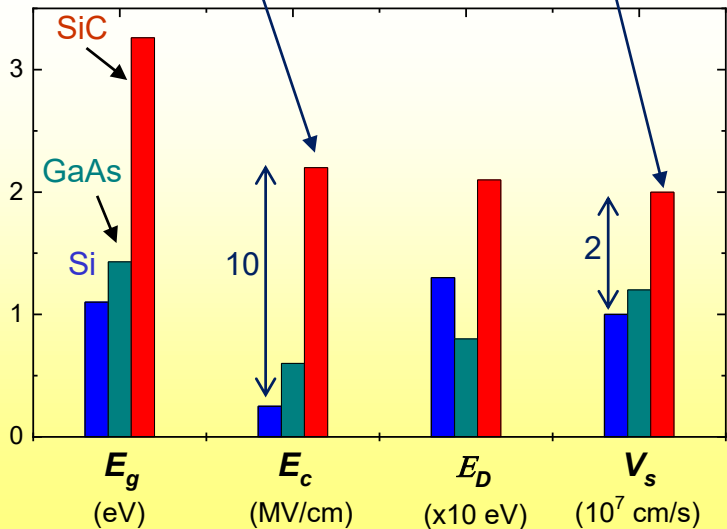


Strength of SiC for Radiation Detection

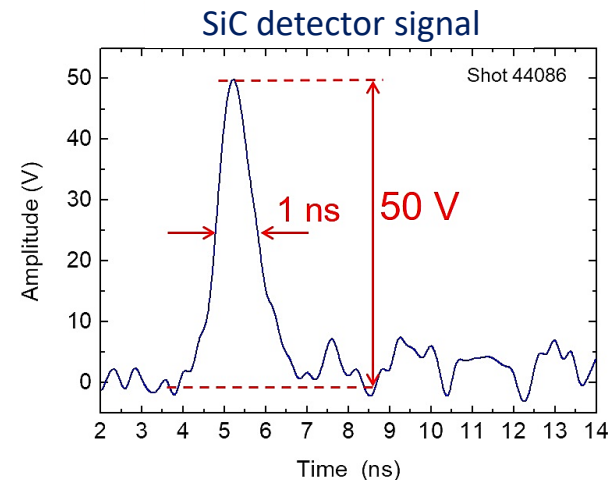
High Critical Field
(2 MV/cm)

High Saturation Velocity
(200 $\mu\text{m}/\text{ns}$)

Experimental Data
Plasma radiation



Asterix – PALS (Prague)
High Power Laser
3 TW / 1 J / 350 ps Laser



SiC detectors: a wide and successful R&D

Plasma

Silicon carbide detector for laser-generated plasma radiation

Giuseppe Bertuccio^{a,b,*}, Donatella Puglisi^{a,b}, Lorenzo Torrisi^{c,d}, Claudio Lanzieri^c

^a Department of Electronics Engineering and Information Science, Politecnico di Milano, Como Campus, Via Anzani 42, 22100 Como, Italy

^b National Institute of Nuclear Physics, INFN sez. Milano, Via Celoria 16, 20133 Milano, Italy

Alpha

High-Resolution Alpha-Particle Spectrometry Using
4H Silicon Carbide Semiconductor Detectors

Frank H. Ruddy, John G. Seidel, Haoqian Chen, Abdul R. Dulloo, Member, IEEE, and
Sei-Hyung Ryu, Member, IEEE

γ -ray, neutrons

Simultaneous Measurement of Neutron and Gamma-Ray Radiation Levels from a
TRIGA Reactor Core Using Silicon Carbide Semiconductor Detectors

A.R. Dulloo^{1*}, F.H. Ruddy¹, J.G. Seidel¹, C. Davison², T. Flinchbaugh² and T. Daubenspeck²

¹Westinghouse Science & Technology Center, 1310 Beulah Road, Pittsburgh, Pennsylvania 15235

Electrons, protons

Radiation tolerance of epitaxial silicon carbide detectors for
electrons, protons and gamma-rays

F. Nava^{a,*}, E. Vittone^b, P. Vanni^c, G. Verzellesi^d, P.G. Fuochi^e,
C. Lanzieri^f, M. Glaser^g

MIP

Particle detectors based on semi-insulating Silicon Carbide

M. Rogalla^{*}, K. Runge, A. Söldner-Rembold

University of Freiburg, Hermann-Herder-Str. 3, 79104 Freiburg, Germany

X-ray

A new generation of X-ray detectors based on silicon carbide

Giuseppe Bertuccio^{a,*}, Roberto Casiraghi^a, Antonio Cetronio^b,
Claudio Lanzieri^b, Filippo Nava^c

^a Department of Electronics Engineering and Information Science, Politecnico di Milano, P.za L. da Vinci 32, Milano 20133, Italy

UV

Demonstration of 4H-SiC visible-blind EUV
and UV detector with large detection area

X. Xin, F. Yan, T.W. Koeth, C. Joseph, J. Hu, J. Wu and
J.H. Zhao

What next?

Large format detectors R&D

What is needed now?

A significant application

Additional information:

see presentation at CPAD Solid State Session

Thursday, 18 March 2021

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